

Customer No. 22,852 Attorney Docket No. 8071.0007

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
Takeshi MITSUISHI et al.	) Group Art Unit: 2872
Application No.: 09/986,907	) Examiner: Joshua Pritchett
Filed: November 13, 2001	) )
For: COMPOSITION FOR VAPOR DEPOSITION, METHOD FOR FORMING AN ANTIREFLECTION FILM, AND OPTICAL ELEMENT	) Confirmation No.: 6647 ) )
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	

## PETITION FOR EXTENSION OF TIME

Applicants petition for a one-month extension of time to reply to the Office action of April 5, 2005. A fee of \$120.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

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Sir:

120.00 OP

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: July 29, 2005

Charles E. Van Horn Reg. No. 40,266